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Sheet 1 of 2711 West Los Altos Road
Tucson, AZ 85704-4105

FORM PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. D-95013A1a	SERIAL NO. (Filed Herewith)		
LIST OF PRIOR ART CITED BY APPLICANT				APPLICANT			
				Ahmad Waleh et al			
				FILING DATE (Filed Herewith)	GROUP		
U.S. PATENT DOCUMENTS							
EXR IN	DOC. NO.	DATE	NAME	CLASS	SUBCLASS		
AA	4,669,544	6/1/87	Nimerick	166	300		
AB	5,030,399	7/9/91	Walles et al	264	83		
AC	5,158,100	10/27/92	Tanaka et al	134	105		
AD	4,179,071	12/18/79	Kozacka	239	397.5		
AE	4,915,912	4/10/90	Walles et al	422	160		
AF	4,778,536	10/18/88	Grebinski	134	36		
AF1	5037506	8/1991	Gupta, et al	134	902		
AG	4,363,673	12/1982	Settineri, et al	134	2		
AH	4,455,175	12/1984	Settineri, et al	134	5		
AI	4,536,222	8/1985	Settineri, et al	134	5		
AJ	5,763,016	12/1998	Levinson, et al	427	510		
AK	5,952,157	9/1999	Kato, et al	430	329		
AL	5,227,001	7/13/93	Tamaki, et al	156	345		
FOREIGN PATENT DOCUMENTS							
	DOC. NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
	AN						
	AO						
	AP						
OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
AR	Stanley Wolf and Richard N. Tauber, "Silicon Processing For The VLSI Era", <i>Process Technology</i> , Vol. 1 (1986), p. 564;						
AS	"Choose The Right Process To Strip Your Photoresist", <i>Semiconductor International</i> , February 1990, pp 83-87;						
AT	"New Concerns In Dry Oxygen Ashing", <i>Semiconductor International</i> , March 1996, p. 44; and						
AU	"What's Driving Resists Dry Stripping?", <i>Semiconductor International</i> , November 1994, pp 61-64.						
AV	Christina M. Cline, "Emerging Technology; Emerging Markets", <i>Precision Cleaning</i> , October 1996, pp 11-19						
AW	Ruth DeJule, "Managing Etch and Implant Residue", <i>Semiconductor International</i> , August 1997, pp 56-63						
EXAMINER A. MARUCCI			DATE CONSIDERED 10/28/07				
EXAMINER: Initial if references considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

PATENT APPLICATION

Page 2 of 2

FORM PTO-1449	ATTY. DOCKET NO. D-95013A1	SERIAL NO. (Filed Herewith)
APPLICANT Ahmad Waleh, et al.		
FILING DATE (Filed Herewith)	GROUP	

REFERENCE DESIGNATION U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
AM	3893869	7/1975	Mayer, et al	134	184
	5024968	6/1991	Engelsberg	134	1
AM	5114834	5/1992	Nachshon, y	216	48
	5531857	7/1996	Engelsberg, et al	134	1
	5643472	7/1997	Engelsberg, et al	134	1

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLAS	TRANSLATION	
						YES	NO
AM	WO9507152	3/1995	Elliott et al	B08B	3/00	x	
AM	WO9717164	5/1997	Genut et al	B23K	26/6	x	

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, etc.)

AM	Hawley's Condensed Chemical Dictionary, P 28, 1993
AM	Egelsberg, "Laser Assisted Cleaning Proves Promising", Precision Cleaning, 1994

EXAMINER	DATE CONSIDERED
<i>MPRU</i>	<i>10/28/02</i>